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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

**COMPLETE IF KNOWN**

Application Number	09/887,767
Confirmation Number	9072
Filing Date	June 21, 2001
First Named Inventor	Whonchee Lee
Group Art Unit	3723
Examiner Name	

Sheet 1 of 1 Attorney Docket No. 108298515US2

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIALS	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
AS	AA	6,176,992		Talieh	1/23/01	—
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**FOREIGN PATENT DOCUMENTS**

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AS	AP	SEIICHI KONDO, NORIYUKI SAKUMA, YOSHIO HOMMA, YASUSHI GOTO, NAOFUMI Ohashi, Hizuru Yamaguchi, and Nobuo Owada, "Abrasive-Free Polishing for Copper Damascene Interconnection", <i>Journal of the Electrochemical Society</i> , 147 (10) 3907-3913 (2000)	
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	AR		

EXAMINER <i>Alvin D. Grant</i>	DATE CONSIDERED <i>4/17/02</i>
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